

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	TOMINAGA KOJI ET AL.	.	)	
			)	Group Art Unit: 2813
Serial No.:	10/550,805		)	
			)	Examiner: Luke, Daniel M.
Filed:	July 12, 2006		)	
			)	Confirmation No. 3990
For:	METHOD FOR FORMING AN		)	
	INSULATING FILM IN A		)	
	SEMICONDUCTOR DEVICE		)	

VIA EFS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR RECONSIDERATION**

Sir:

This Request for Reconsideration is respectfully submitted in response to the Final Office Action dated August 24, 2010. If there are any charges with respect to this Request for Reconsideration or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.